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CONFIRMATION NO. 9391

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10/576,321	04/19/2006	438	1722	12054-0059

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**\*\* CONTINUING DATA \*\*\*\*\***  
 This application is a 371 of PCT/JP04/11050 08/02/2004

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***  
 JAPAN 2003-360251 10/21/2003

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***  
 12/14/2006

Foreign Priority claimed 35 USC 119(a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No /MARISSA W CHAET/ Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 5	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
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**ADDRESS**  
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 UNITED STATES

**TITLE**  
 Process for producing high-resistance silicon wafers and process for producing epitaxial wafers and soi wafers (as amended)

<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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